Latest News on High Average Power Operation at PITZ.

Yves Renier, DESY, Zeuthen site, Germany

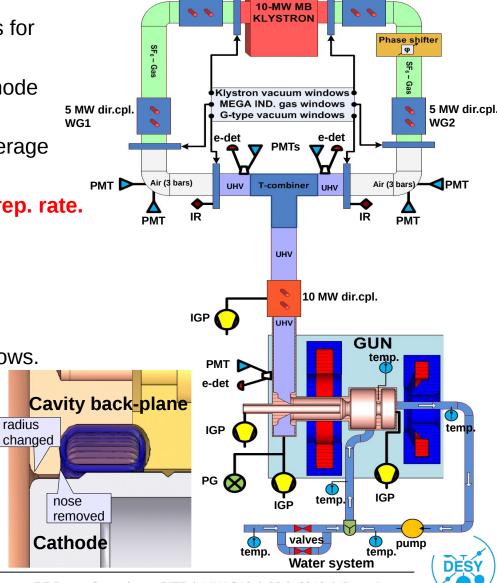
> Motivation:

- Develop, test and characterize e- sources for FLASH and the European XFEL.
- Long bunch train (SC linac) and high cathode field.
- Stable and reliable operation at 42kW average power:

6.5 MW, 650 us RF pulse length, 10Hz rep. rate.



- Normal conducting L-band gun.
- New design of cathode spring holder.
- Two pre-conditioned DESY-type RF windows.
- Optimized vacuum window position.
- Sensitive settings for ILs during conditioning phase.
- Fast IL system (few us).
- only vacuum is a slow IL system.



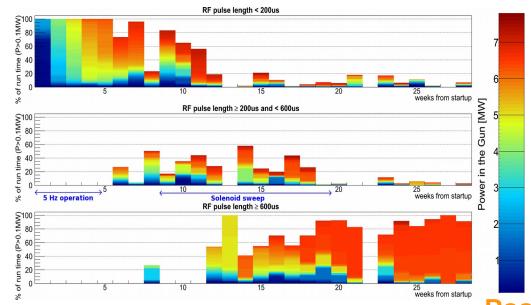
dir.cpl.

dir.cpl.



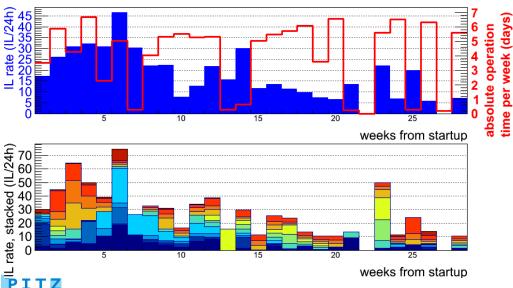
Power, Pulse Length and ILs History.

(all data with >0.1MW peak power in the gun are taken into account)



- Conditioning started on 7.3.2016.
- No signature of cathode springs failure. New cathode spring design works.
- 16 weeks to reach 6.5 MW @ 650 us (XFEL nominal parameters).
- More than 80% of operation above 6 MW and above 600 us in the last month (goal >99%), still increasing.

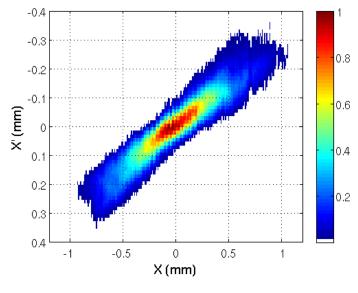
Poster MOPRC002, today 16h - 16h30

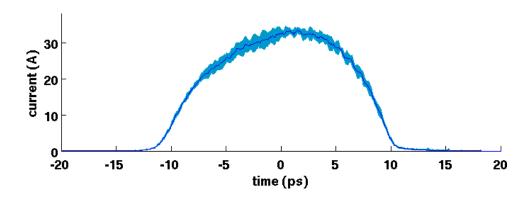


- type of ILs Pressure Gun.IGP2 Pressure Gun.IGP1 (151)e- Detector Gun Coupler (195) PMT Gun Coupler (135)PMT Vacuum Window WG1 Vacuum (388) PMT Vacuum Window WG2 Vacuum (246) PMT RF Window WG2 Air (192) PMT Vacuum Window WG2 Air (222) Maximum Reflection WG1 (425) Maximum Reflection WG2 (339) Maximum Reflection 10MW (464) Others (109)
- > The IL rate decreases.
- Different type of ILs, changing with time.
- Significant amount of ILs are due to the RF transmission line.



Electron Beam Characterization (E_{cath}=60 MV/m, 0.5 nC charge, 11 ps Gaussian).





- > After optimization (solenoid, laser spot size):
 - Projected transverse emittance: 0.80±0.04 mm.mrad
 - Bunch length: 16.3±0.4 ps FWHM (32 A peak current)
 - Brightness ($\frac{2I_{peak}}{\varepsilon_x \varepsilon_y}$): 100 A.mm⁻².mrad⁻²
- Better than specifications for the European XFEL initial phase.
- With improved laser shaping, we will go far beyond nominal specifications.

